

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Not for submission under 37 CFR 1.99)	Application Number		10599957	
	Filing Date		2006-10-16	
	First Named Inventor	Yasuyuki Naito		
	Art Unit			
	Examiner Name			
Attorney Docket Number		NGB-41324		

U.S.PATENTS							Remove
Examiner Initial*	Cite No	Patent Number	Kind Code ¹	Issue Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear	
	1						

If you wish to add additional U.S. Patent citation information please click the Add button.

Add

U.S.PATENT APPLICATION PUBLICATIONS							Remove
Examiner Initial*	Cite No	Publication Number	Kind Code ¹	Publication Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear	
	1						

If you wish to add additional U.S. Published Application citation information please click the Add button.

Add

FOREIGN PATENT DOCUMENTS							Remove	
Examiner Initial*	Cite No	Foreign Document Number ³	Country Code ² j	Kind Code ⁴	Publication Date	Name of Patentee or Applicant of cited Document	Pages,Columns,Lines where Relevant Passages or Relevant Figures Appear	T ⁵
/B.S./	1	7-221322	JP		1995-08-18			<input type="checkbox"/>
/B.S./	2	2002-534285	JP		2002-10-15			<input type="checkbox"/>

If you wish to add additional Foreign Patent Document citation information please click the Add button.

Add

NON-PATENT LITERATURE DOCUMENTS							Remove
---------------------------------	--	--	--	--	--	--	--------

Receipt date: 02/24/2009

Application Number	10599957	10599957 - GAU: 2817
Filing Date	2006-10-16	
First Named Inventor	Yasuyuki Naito	
Art Unit		
Examiner Name		
Attorney Docket Number	NGB-41324	

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Examiner Initials*	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, pages(s), volume-issue number(s), publisher, city and/or country where published.	T ⁵
/B.S./	1	KANG et al., "Amplitude Detecting Michromechanical Resonating Beam Magnetometer", IEEE, The Eleventh Annual International Workshop on MEMS 98, 01/1998 (Cited on ISR)	<input type="checkbox"/>
/B.S./	2	BANNON, III, et al., "High-Q HF Microelectromechanical Filters", IEEE Journal of Solid-State Circuits, Vol. 35, No. 4, 04/2000, pages 512-526 (Cited on ISR)	<input type="checkbox"/>

If you wish to add additional non-patent literature document citation information please click the Add button

EXAMINER SIGNATURE

Examiner Signature	/Barbara Summons/	Date Considered	03/29/2009
--------------------	-------------------	-----------------	------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through a citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ See Kind Codes of USPTO Patent Documents at www.USPTO.GOV or MPEP 901.04. ² Enter office that issued the document, by the two-letter code (WIPO Standard ST.3). ³ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁴ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁵ Applicant is to place a check mark here if English language translation is attached.